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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re PATENT application of

Koichiro TANAKA

Serial No. 10/787,191

Filed: February 27, 2004

For: LASER IRRADIATION APPARATUS,

LASER IRRADIATION METHOD, AND

METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE

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Group Art Unit: 2828

Examiner: Minsun Harvey

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on December 5, 2005

SECOND REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

Eric J. Robinson
Reg. No. 38,285

Robinson Intellectual Property Law Office, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789
(571) 434-9499 (Fax)